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A.B.T.

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re the Application of:

JINNO et al.

Serial No.: 09/753,397

Filed: January 3, 2001

Atty. File No.: 2933SE-62-DIV

For: "THIN FILM TRANSISTOR AND
METHOD OF FABRICATING THE
SAME"

BOX AF
Commissioner for Patents
Washington, D.C. 20231

Group Art Unit: 2815

Examiner: Eckert II, George C.

AMENDMENT AFTER FINAL

CERTIFICATE OF MAILING

I HEREBY CERTIFY THAT THIS CORRESPONDENCE OR FEE IS
BEING DEPOSITED WITH THE UNITED STATES POSTAL
SERVICE AS FIRST CLASS MAIL IN AN ENVELOPE ADDRESSED
TO ASSISTANT COMMISSIONER FOR PATENTS, WASHINGTON,
D.C. 20231 ON THIS 23 DAY OF DEC 2002.
SHERIDAN ROSS P.C.

BY:

Dear Sir:

Applicants submit this Amendment After Final to address the final Office Action having a mailing date of September 23, 2002. Although no fees are believed due in connection with the filing of this Amendment After Final, please charge any fees deemed necessary to Deposit Account No. 19-1970. Reconsideration and withdrawal of the rejections of the claims pending in the above-referenced application are respectfully requested in view of the following amendments and remarks.

AMENDMENTS

Please amend the above-identified patent application as follows:

IN THE CLAIMS:

Please amend Claims 7, 8 and 9 as follows:

7. (Twice Amended) A bottom gate thin film transistor comprising

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